IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Filing Date January 15, 2002 Assignee Micron Technology, Inc. Examiner Schillinger, L.

Title: Methods of Forming Transistors

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References –See Attached Form PTO-1449

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449, copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of the referenced art is respectfully requested.

Respectfully submitted,

Dated:

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